

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hitoshi SAOMOTO et al.**

Art Unit: **2828**

Application Number: **10/592,943**

Examiner: **Michael W. Carter**

Filed: **September 15, 2006**

Confirmation Number: **8662**

For: **SEMICONDUCTOR LASER ELEMENT AND
MANUFACTURING METHOD THEREOF**

Attorney Docket Number: **062998**

Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCESSING REQUESTED

MAIL STOP: AF

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

June 4, 2010

Sir:

This is in response to the Office Action dated March 10, 2010, and having a response due date set for June 10, 2010. The following amendments and remarks are respectfully submitted.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.